## **IN THE CLAIMS**

Please cancel claims 1-8 and 11-17, without prejudice or disclaimer.

## 1.-8. (Canceled).

9. (Currently Amended) A distributed feedback type semiconductor layer diode comprising:

a semiconductor substrate;

an AlGaInAs optical guide layer formed on said semiconductor substrate, a diffraction grating having a phase shift region being formed between said semiconductor substrate and said AlGaInAs optical guide layer; and

a 1.0% or more compression-strained AlGaInAs multiple quantum well active layer formed on said AlGaInAs optical guide layer, wherein

$$\kappa L + 0.05 \cdot \Delta \lambda \ge 3.4 \cdot 3.0$$

where  $\kappa$  is a coupling coefficient of said diffraction grating,

L is a cavity length of said diode, and

 $\Delta\lambda$  is a detuning amount denoted by  $\Delta\lambda=\lambda_g$  -  $\lambda$  where  $\lambda_g$  is a gain peak wavelength of said diode and  $\lambda$  is an oscillation wavelength of said diode.

**10.** (Currently Amended) A distributed feedback type semiconductor layer diode comprising:

a semiconductor substrate;

an AlGaInAs optical guide layer formed on said semiconductor substrate, a diffraction grating having a phase shift region being formed between said semiconductor substrate and said AlGaInAs optical guide layer; and

a 1.0% or more tensile-strained AlGaInAs multiple quantum well active layer formed on said AlGaInAs optical guide layer, wherein

$$\kappa L + 0.05 \cdot \Delta \lambda \ge 3.4 \ \underline{3.0}$$

where  $\kappa$  is a coupling coefficient of said diffraction grating,

L is a cavity length of said diode, and

 $\Delta\lambda$  is a detuning amount denoted by  $\Delta\lambda=\lambda_g$  -  $\lambda$  where  $\lambda_g$  is a gain peak wavelength of said diode and  $\lambda$  is an oscillation wavelength of said diode.

## 11.-17. (Canceled).

- 18. (New) The distributed feedback type semiconductor laser diode as set forth in claim 9, wherein said optical guide layer comprises A1GaInAs.
- 19. (New) The distributed feedback type semiconductor laser diode as set forth in claim 10, wherein said optical guide layer comprises A1GaInAs.